



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Farnworth et al.

Serial No.: 10/666,930

Filed: September 19, 2003

For: METHOD AND APPARATUS FOR
SUPPORTING WAFERS FOR DIE
SINGULATION AND SUBSEQUENT
HANDLING

Examiner: Unknown

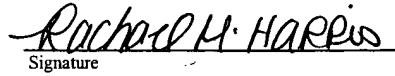
Group Art Unit: 2812

Attorney Docket No.: 2269-5529US
(02-0766.00/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

January 5, 2004
Date


Signature

Rachael M. Harris
Name (Type/Print)

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with the duty to disclose information material to patentability pursuant to 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 or PTO/SB/08 be considered by the Examiner and made of record. Copies of the listed documents are enclosed pursuant to 37 C.F.R. § 1.98(a).

In accordance with 37 C.F.R. § 1.97(g) and (h), filing of this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b). Further, no representation is made by Applicants herein that no other possible material information as defined in 37 C.F.R. § 1.56 (b) exists.

U.S. Patent Documents

<u>U.S. Patent No.</u>	<u>Publication Date</u>	<u>Patentee</u>
6,251,488	06/26/01	Miller et al.
6,259,962	07/10/01	Gothait
6,268,584	07/31/01	Keicher et al.
6,391,251	05/21/02	Keicher et al.
6,562,661	05/13/03	Grigg

Other Documents

U.S. Patent Application Publication 2002/0171177 A1 to Kritchman et al., dated November 21, 2002

U.S. Patent Application Publication 2003/0151167 A1 to Kritchman et al., dated August 14, 2003

U.S. Patent Application Publication 2003/0176021 A1 to Grigg, dated September 18, 2003

MILLER et al., "Maskless Mesoscale Materials Deposition", Deposition Technology, September 2001, pages 20-22

MILLER, "New Laser-Directed Deposition Technology", Microelectronic Fabrication, August 2001, page 16

Webpage, Objet Prototyping the Future, "Objet FullCure700 Series", 1 page

Webpage, Objet Prototyping the Future, "How it Works", 2 pages

U.S. Patent Application No. 09/512,203, filed February 24, 2000, entitled "Tape Stiffener, Semiconductor Device Component Assemblies Including Same, and Stereolithographic Methods for Fabricating Same", inventor Ford B. Grigg

U.S. Patent Application No. 10/666,742, filed September 19, 2003, entitled "Support Structure for Thinning Semiconductor Substrates and Thinning Methods Employing the Support Structure", inventor Wood et al.

Applicants offer to supply any explanation or discussion of the documents which the Examiner feels is necessary or desirable and which is requested.

This Supplemental Information Disclosure Statement is filed before the mailing date of a first Office Action on the merits.

Respectfully submitted,



Tawni L. Wilhelm
Registration No. 47,456
Attorney for Applicant(s)
TRASKBRITT
P.O. Box 2550
Salt Lake City, Utah 84110-2550
Telephone: 801-532-1922

Date: January 5, 2004

TLW/sls:rmh

Enclosures: Form PTO-1449 or PTO/SB/08

Copy of documents cited

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Complete if Known

Application Number	10/666,930
Filing Date	September 19, 2003
First Named Inventor	Farnsworth et al.
Group Art Unit	2812
Examiner Name	Unknown
Attorney Docket Number	5529US (02-0766.00/US)

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner Signature		Date Considered	
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***EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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PTO/SB/08B(10-01)

Approved for use through 10/31/2002. OMB 0651-0031

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Application Number	10/666,930
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First Named Inventor	Farnsworth et al.
Group Art Unit	2812
Examiner Name	Unknown

Attorney Docket Number 5529LIS (02-0766 00/LIS)

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		U.S. Patent Application Publication 2002/0171177 A1 to Kritchman et al., dated November 21, 2002	
		U.S. Patent Application Publication 2003/0151167 A1 to Kritchman et al., dated August 14, 2003	
		U.S. Patent Application Publication 2003/0176021 A1 to Grigg, dated September 18, 2003	
		MILLER et al., "Maskless Mesoscale Materials Deposition", Deposition Technology, September 2001, pages 20-22	
		MILLER, "New Laser-Directed Deposition Technology", Microelectronic Fabrication, August 2001, page 16	
		Webpage, Objet Prototyping the Future, "Objet FullCure700 Series", 1 page	
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¹ Unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.

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